



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of )

Shunpei YAMAZAKI )

Serial No. 09/433,705 )

Filed: November 4, 1999 )

For: METHOD OF FABRICATING  
A SEMICONDUCTOR DEVICE )

) Group Art Unit: 2811

) Examiner: S. Loke

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with  
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*[Signature]*

AMENDMENT AND RESPONSE TO ELECTION REQUIREMENT

Honorable Commissioner for Patents

Washington, D.C. 20231

Sir:

In response to the Office Action of June 5, 2001, please amend the subject application as follows:

IN THE CLAIMS:

✓ Cancel claims 1-12 without prejudice to applicant's right to file a divisional application with respect thereto.

REMARKS

In response to the election requirement in the Office Action of June 5, 2001, Applicant hereby elects without traverse the Group I claims - that is, claims 13-41, drawn to a semiconductor device.

Examination on the merits is requested.

Respectfully submitted,

*[Signature]*

Eric J. Robinson  
Registration No. 38,285

NIXON PEABODY LLP  
8180 Greensboro Drive, Suite 800  
McLean, Virginia 22102  
(703) 790-9110